

LIST OF PUBLICATIONS
CITED BY APPLICANT

Attorney Docket No.
SEL 170

Serial No.
09/532,915

Applicant
Masahiko HAYAKAWA et al

Filing Date
March 22, 2000

Group
2811

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
A.S.	JP 10-135469	05/22/98	Semiconductor Energy Laboratory Co., Ltd.			10/24/96

OTHER PUBLICATIONS
(Including Author, Title, Date, Pertinent Pages)

A.S.	English abstract re Japanese patent application no. 10-135469, published May 22, 1998.
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EXAMINER:

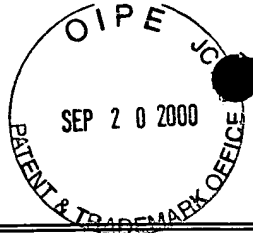
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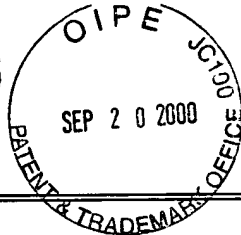
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			<u>Applicant</u> Masahiko HAYAKAWA et al			
			<u>Filing Date</u> March 22, 2000		<u>Group</u> 2811	
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
A.S. ↓	5,247,190	09/21/93	Friend et al	257	40	12/28/90
	5,399,502	03/21/95	Friend et al	437	1	05/05/93
	5,594,569	01/14/97	Konuma et al	349	122	07/20/94
	5,643,826	07/01/97	Ohtani et al	437	88	10/25/94
	5,923,962	07/13/99	Ohtani et al	438	150	04/28/95
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
A.S. ↓ ✓	WO 90/13148	11/01/90	Cambridge Research and Innovation, Ltd.			04/18/90
	JP 7-130652	05/19/95	Semiconductor Energy Laboratory Co., Ltd.			10/29/93
	JP 7-335900	12/22/95	Semiconductor Energy Laboratory Co., Ltd.			06/09/94
	JP 8-078329	03/22/96	Semiconductor Energy Laboratory Co., Ltd.			09/05/94
	JP 10-092576	04/10/98	Cambridge Display Technology, Ltd.			04/18/97
	JP 10-135468	05/22/98	Semiconductor Energy Laboratory Co., Ltd.			10/24/96
	JP 10-247735	09/14/98	Semiconductor Energy Laboratory Co., Ltd.			03/03/97

Ahmed N. Selim

p.02.01



OTHER PUBLICATIONS

(Including Author, Title, Date, Pertinent Pages)

As

Yeh, J.L., et al, "Structural and Optical Properties of Amorphous Silicon Oxynitride," *J. Appl. Phys.*, vol.79, no. 2, pp. 656-663, January 15, 1996.
Inui, S. et al, "Thresholdless Antiferroelectricity in Liquid Crystals and its Application to Displays," *J. Mater. Chem.*, vol. 6, no. 4, pp. 671-673, 1996.
Yoshida, T. et al, "A Full-Color Thresholdless Antiferroelectric LCD Exhibiting Wide Viewing Angle with Fast Response Time," *SID 97 Digest*, pp. 841-844, 1997.
Furue, H. et al, "Characteristics and Driving Scheme of Polymer-Stabilized Monostable FLCD Exhibiting Fast Response Time and High Contrast Ratio with Gray-Scale Capability," *SID 98 Digest*, pp. 782-785, 1998.
Terada, M. et al, "Half-V Switching Mode FLC," *Proceedings of the 46th Applied Physics Association Lectures*, Society for Applied Physics of Japan, 28p-V-8, p. 1316, March, 1999.
Yoshihara, T. et al, "Time Division Full Color LCD by Ferroelectric Liquid Crystal," *EKISHO*, vol. 3, no. 3, pp. 190-194, 1999.
Schenk, H. et al, "Polymers for Light Emitting Diodes," *EURODISPLAY '99*, Proceedings of the 19th International Display Research Conference, September 6-9, 1999, Berlin, Germany, pp. 33-37, 1999.
English abstract re Japanese patent application no. 7-130652, published May 19, 1995.
English abstract re Japanese patent application no. 7-335900, published December 22, 1995.
English abstract re Japanese patent application no. 8-078329, published March 22, 1996.
English abstract re Japanese patent application no. 10-092576, published April 10, 1998.
English abstract re Japanese patent application no. 10-135468, published May 22, 1998.
English abstract re Japanese patent application no. 10-247735, published September 14, 1998.

EXAMINER:

Amrith S. Srinivasan

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